


Search Notes 	Application/Control No. 10598502	Applicant(s)/Patent Under Reexamination NAKAMURA ET AL.
	Examiner Mark L Shevin	Art Unit 1793

SEARCHED			
Class	Subclass	Date	Examiner
148	425	11/03/2008	MLS
204	298.12, 298.13	11/03/2008	MLS
420	435, 436	11/03/2008	MLS

SEARCH NOTES		
Search Notes	Date	Examiner
Inventor name search (EAST, eDan, and Google Scholar)	11/03/2008	MLS
Assignee name search (Nippon Mining...)	11/03/2008	MLS
IPC: C22C 19/07 , C23C 14/34,35 , H01F 41/18 , H01L 21/285	11/03/2008	MLS
Derwent: M13-G02A , M26-B08	11/03/2008	MLS
Search reports and written opinions for instant application and co-pending 10-598,997	11/03/2008	MLS
NPL search for Co-Cr-Pt-B sputtering target, lathe machining of targets, and surface roughness / polishing of targets	11/03/2008	MLS
Discussion with Jessee Roe about claims	11/03/2008	MLS
Updated search (US classes, IPC, Derwent, Inventor and Assignee name search)	05/3/2009	MLS
Updated search (US classes, IPC, Derwent, Inventor and Assignee name search)	12/15/2009	MLS

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

/Mark L. Shevin/	
------------------	--